

18334 U.S. PTO
07/15/03

UTILITY PATENT APPLICATION
UNDER 37 CFR 1.53(b)

15535 U.S. PTO
10/619191
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Mail Stop Utility
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Case Docket No. 60188-578

Sir:

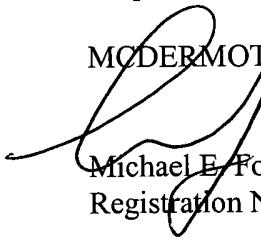
Transmitted herewith for filing is the patent application of:

INVENTOR: **Shinichi IMAI, Masaki TAGUCHI**
FOR: **SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION
APPARATUS**

Enclosed are:

- 47 pages of specification, claims, abstract.
 Declaration and Power of Attorney.
 Priority Claimed - **Japanese Patent Application No. 2002-205667**
 Certified copy of _____
 15 sheets of formal drawing.
 An assignment of the invention to _____
and the assignment recordation fee.
 An associate power of attorney.
 Information Disclosure Statement, Form PTO-1449 and reference.
 Return Receipt Postcard

Respectfully submitted,


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